



Attorney Docket no: SEL 299

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2823
#8 / Supp
RDS
5-27-03
Estab

In re Application of:

Takashi Hamada et al.

Serial No.: 10/051,064

Filed: January 18, 2002

Art Unit: 2823

Examiner: F. Toledo

For: Semiconductor Device and Method
of Manufacturing the Same

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to:
the Commissioner for Patents, Washington, D.C. 20231
on March 7, 2003

Debra Howe

Debra Howe
Signature

3-7-03
Date

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992, 1135 OG 23-24, Applicants hereby call the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. A copy of each of the documents is enclosed herewith for the Examiner's consideration.

No inference should be drawn that any apparatus disclosed is equivalent to the subject invention.


The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

RECEIVED
MAR 17 2003
1C 2803 MAIL ROOM

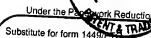
Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

Applicants do not believe that a fee is due since the Office Action mailed on January 21, 2002 was strictly in regards to an election requirement and not on the merits. In addition, a Notice of Allowance or issue fee notification has not been received in this case. However, if any such fee is required, please charge our Deposit Account No. 50/1039.

Respectfully submitted,


Mark J. Murphy
Registration No. 34,225

COOK, ALEX, McFARRON, MANZO,
CUMMINGS & MEHLER, Ltd.
200 West Adams Street, Suite 2850
Chicago, Illinois 60606
(312) 236-8500



Approved for use through 04/30/2003. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
a collection of information unless it contains a valid OMB control number.
Complete if Known

(Use as many sheets as necessary)

Sheet	1
-------	---

of 1

Complete if Known

Application Number	10/051,064
Filing Date	January 18, 2002
First Named Inventor	Takashi Hamada et al
Art Unit	2823
Examiner Name	Toledo, Fernando L
Attorney Docket Number	SEL 299

OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS
 Include name of the author (in CAPITAL LETTERS)

OTHER PRIOR ART--NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.†	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
		JONES et al., Boron Diffusion upon Annealing of Laser Thermal Processed..., IEEE, 2000, pp.111-114 ✓	
		LLEWELLYN et al., Implantation and Annealing of Cu in InP for Electrical..., IEEE, 1997, pp. 313-316 ✓	

MAR 17 2013
 IC 2600 MAIL ROOM

RECEIVED

RECEIVED	MAR 17 2003	TO 2800 MAIL ROOM
----------	-------------	-------------------

Examiner
SignatureDate
Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Considered
<p>considered. Include copy of this form with next communication to applicant. Draw line through citation if not in conformance and not</p> <p>1 Applicant's unique citation designation number.</p>

1. Applicant: Include copy of this form with next communication to USPTO in accordance with MPEP 606. Draw line through citation if not in conformance and not a standard: include unique citation designation number (optional). 2. Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to be filed by the USPTO to process an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including amount of time you will need to complete this form and/or suggestions for reducing this burden. This burden varies depending upon the individual case. Any comments on this form should be sent to the Commissioner of Patents, Washington, DC 20231. Do NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.